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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): H. MORIOKA, et al

Serial No.: (not yet assigned)

Filed: March 14, 2001

For: METHOD AND APPARATUS FOR ANALYZING THE STATE OF
GENERATION OF FOREIGN PARTICLES IN
SEMICONDUCTOR FABRICATION PROCESS

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents
Washington, D.C. 20231

March 14, 2001

Sir:

In the matter of the above-identified application,
this information disclosure statement is being submitted with
the following citation as specified in 37 CFR 1.97(d).

"A copy of any patent, publication or other
information listed in an information disclosure statement
is not required to be provided if it was previously cited
by or submitted to the Office in a prior application,
provided that the prior application is properly
identified in the statement and relied upon for an
earlier filing date under 35 U.S.C. 120."

Applicant(s) are submitting herewith a copy of Form PTO-
1449 which list documents cited in parent application(s) U.S.
Serial No. 08/535,577, filed September 28, 1995, U.S. Serial
No. 08/046,720, filed April 16, 1993, now U.S. Patent No.
5,463,459, U.S. Serial No. 07/679,313, filed April 2, 1991,
now U.S. Patent No. 5,233,191 and U.S. Serial No. 07/778,363,
filed October 17, 1991, now U.S. Patent No. 5,274,434.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (501.30598CC3) and please credit any excess fees to such deposit account.

Respectfully submitted,



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